

Mounting Apparatus for Mounting of a Structured Wafer

Abstract

This invention relates to a mounting apparatus for mounting and fixing of a substrate 10 on one structure side 10s of the substrate 10, which side has structures 11 with a mounting element 3 with a flat mounting surface 3o for supporting the structures 11 and a suction surface F_2 which penetrates the mounting surface 3o solely in an outer ring surface 8 for effecting a fluid flow which suctions the substrate 10.

Figure 1a